

<b>Search Notes</b>	<b>Application/Control No.</b>	<b>Applicant(s)/Patent Under Reexamination</b>
	10573356	SHIMADA ET AL.
	<b>Examiner</b>	<b>Art Unit</b>
	RENE GARCIA JR	2853

## SEARCHED

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
347	64, 71, 72	03/12/09	RG
347	20, 56-59, 61-65, 67, 68	03/12/09	RG

## SEARCH NOTES

<b>Search Notes</b>	<b>Date</b>	<b>Examiner</b>
Attached Updated EAST Search History	03/12/09	RG
Focused Text search of Piezoelectric structures utilizing protective/insulative film/layers	03/12/09	RG

## INTERFERENCE SEARCH

<b>Class</b>	<b>Subclass</b>	<b>Date</b>	<b>Examiner</b>
347	64, 71, 72	03/12/09	RG
	347/64,71,72.ccls. and ((insulat\$3 protective protection) near3 (film layer)) with (electrode lead contact) near4 (cover\$3)	03/12/09	RG
	(channel and pressure and nozzle and piezoelectric and electrode near3 (upper lower top bottom) with stress and ((insulat\$3 protective protection) adj2 (film layer)) with stress and (compressive compression) near3 stress)	03/12/09	RG

/R. G./  
Examiner.Art Unit 2853